



Application No. 09/313,659
SEC.0636
STATUS REQUEST
January 19, 2007

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :
Won-suk Yang et al. : Mail Stop Petitions
Serial No. 09/313,659 : Office of Petitions
Filed May 18, 1999 :

MULTILAYER INTERCONNECTION STRUCTURE OF A SEMICONDUCTOR

SECOND STATUS INQUIRY


U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

Applicants received a favorable Decision On Petition dated July 8, 2006. The Decision indicated that the application would be return to the Examiner for further prosecution. To date, Applicants have received no further communications from the Examiner.

Please immediately inform the undersigned as to the status of the present application, and in particular, when issuance of a communication on the merits is anticipated.

Respectfully submitted,
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